	L #	Hits	Туре	Search Text	DBs
1	L1	322	BRS	cocrb cocrptb cocrpttab coptcrb coptcrtab co-cr-b co-cr-pt-b co-cr-pt-ta-b co-pt-cr-b co-pt-cr-b	USPA T; US-P GPUB; ; EPO; JPO; DERW ENT; IBM_ TDB
2	L2	12403 6	BRS	magnetic adj recording	USPA T; US-P GPUB; ; EPO; JPO; DERW ENT; IBM_ TDB
3	L3	294	BRS _.	1 and 2	USPA T; US-P GPUB; EPO; DERW ENT; IBM_ TDB
4	L4	21461 66	BRS	perpendicular vertical	USPA T; US-P GPUB; FPO; JPO; DERW ENT; IBM_ TDB

	L #	Hits	Туре	Search Text	DBs
5	L5	170	BRS	3 and 4	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
6	L6	44492	BRS	coercivity hc "h.sub.c"	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
7	L7	20535	BRS	soft adj magnetic	USPA T; US-P GPUB; ; EPO; JPO; DERW ENT; IBM_ TDB
8	L8	18388	BRS	keeper	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB

	L #	Hits	Туре	Search Text	DBs
9	L 9	8	BRS	5 and 8	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
10	L10	1422	BRS	nial	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
11	L11	84	BRS	6 and 10 and 2 and 4	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
12	L12	84	BRS	thickness and 11	USPA T; US-P GPUB; ; EPO; JPO; DERW ENT; IBM_ TDB

	ь#	Hits	Туре	Search Text	DBs
13	L13	55112 8	BRS	protective overcoat overlayer	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
14	L14	72	BRS	12 and 13	USPA T; US-P GPUB; ; EPO; JPO; DERW ENT; IBM_ TDB
15	L15	2	BRS	14 and 8	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
16	L16	38091	BRS	hc "h.sub.c"	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB

	L #	Hits	Туре	Search Text	DBs
17	L17	1858	BRS	2 and 4 and 16	USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB
18	L18	11606	BRS	underlayer	USPA T; US-P GPUB; EPO; DERW ENT; IBM_ TDB
19	L19	257	BRS	17 and 18	USPA T; US-P GPUB; EPO; DERW ENT; IBM_ TDB
20	L20	15670 70	BRS	thickness	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB

				,	l l
	ъ#	Hits	Туре	Search Text	DBs
21	L21	253	BRS		USPA T; US-P GPUB; FPO; JPO; DERW ENT; IBM_ TDB
22	L23	18737	BRS	7 8	USPA T
23	L24	599	BRS	20 near5 23	USPA T
24	L25	20	BRS	19 and 24	USPA T

(FILE 'HOME' ENTERED AT 15:34:32 ON 25 JUL 2003)

FILE 'REGISTRY' ENTERED AT 15:34:59 ON 25 JUL 2003

L1 55 S, CO.CR.B/RC

26 S CO.CR.PT.B/RC

L3 2 S CO.CR.PT.TA.B/RC

FILE 'CAPLUS' ENTERED AT 15:35:41 ON 25 JUL 2003

L4 61 S L1 OR L2 OR L3

L5 22059 S MAGNETIC (A) RECORDING

L6 200659 S PERPENDICULAR OR VERTICAL

L7 7 S L4 AND L5 AND L6

=> s 14 and 15

L2

L8 24 L4 AND L5

=> s 18 not 17

L9 17 L8 NOT L7

=> d 1- all

```
L7
     ANSWER 1 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
AN
     2003:396311 CAPLUS
DN ·
    138:394737
     Perpendicular magnetic recording medium and
ΤI
     magnetic disk recording apparatus
IN
     Hikosaka, Takashi; Oikawa, Soichi; Nakamura, Futoshi; Iwasaki, Takeshi;
     Sakai, Hiroshi; Sakawaki, Akira
PA
     U.S. Pat. Appl. Publ., 13 pp.
SO
     CODEN: USXXCO
DT
     Patent
LA
     English
IC
     ICM B32B027-06
    428480000; 428694000MM; 428693000
NCL
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56, 75
FAN.CNT 1
     PATENT NO.
                    KIND DATE
                                          APPLICATION NO. DATE
PΙ
    US 2003096127 A1 20030522
                                          US 2002-234719 20020905
     JP 2003157516
                     A2 20030530
                                          JP 2001-358205 20011122
PRAI JP 2001-358205 A
                          20011122
     A perpendicular magnetic recording material
     with high thermal-decay resistance and a high signal-to-noise ratio and
     decreased thickness of the magnetic recording layer is
     claimed. Epitaxial growth of a magnetic grain crystal in a
    perpendicular magnetic recording layer is
     interrupted to achieve this end. For example in a magnetic disk
     fabrication, a 1st perpendicular film of Co73Pt5Cr22 was
     deposited by sputtering and a 2nd perpendicular layer of
     Co64Pt24Cr12 was sputter deposited in an Ar-O2 atm. The 2nd layer had a
     lattice const. >2% that of the first layer. The signal-to-noise ratio was
     23.0 dB compared to 20.5 dB for disks without the 2nd layer.
ST
     sputter epitaxy interruption perpendicular magnetic
     recording disk noise
IT
     Epitaxy
    Magnetic disks
       Magnetic recording materials
     Sputtering
        (perpendicular magnetic recording medium
        for disk prepd. by interrupted sputter epitaxy)
TΤ
     7782-44-7, Oxygen, processes 301524-32-3, Chromium 16, cobalt 64,
     platinum 20 (atomic)
    RL: CPS (Chemical process); NUU (Other use, unclassified); PEP (Physical,
     engineering or chemical process); PROC (Process); USES (Uses)
        (perpendicular magnetic recording medium
        for disk prepd. by interrupted sputter epitaxy)
TΤ
     7440-37-1, Argon, uses
     RL: NUU (Other use, unclassified); USES (Uses)
        (perpendicular magnetic recording medium
        for disk prepd. by interrupted sputter epitaxy)
IT
     7440-44-0, Carbon, processes 7440-58-6, Hafnium, processes
     129516-28-5, Chromium 12, cobalt 64, platinum 24 (atomic)
                                                                500588-49-8,
    Ruthenium 90, titanium 10 (atomic)
                                        527698-12-0, Chromium 22, cobalt 73,
     platinum 5 (atomic) 527698-13-1, Chromium 18, cobalt 62, platinum 20
              527698-14-2, Chromium 12, cobalt 68, platinum 20 (atomic)
     527698-15-3, Boron 1, chromium 20, cobalt 74, platinum 5 (atomic)
     527698-16-4, Chromium 21, cobalt 55, platinum 24 (atomic)
    RL: PEP (Physical, engineering or chemical process); PYP (Physical
     process); TEM (Technical or engineered material use); PROC (Process); USES
     (Uses)
        (perpendicular magnetic recording medium
        for disk prepd. by interrupted sputter epitaxy)
```

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IT
     191474-05-2P
     RL: SPN (Synthetic preparation); TEM (Technical or engineered material
     use); PREP (Preparation); USES (Uses)
        (perpendicular magnetic recording medium
        for disk prepd. by interrupted sputter epitaxy)
     ANSWER 2 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
L7
     2003:376200 CAPLUS
AN
DN
     138:361602
     Design of a layered thin-film media for perpendicular
TI
     magnetic recording
     Zheng, Min; Choe, Geon
IN
PA
     USA
SO
     U.S. Pat. Appl. Publ., 11 pp.
     CODEN: USXXCO
DT
     Patent
LA
     English
IC
     ICM C23C014-00
    428195000; 428694000TS; 204192100
NCL
CC
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 55, 56, 57
FAN.CNT 1
     PATENT NO.
                    KIND DATE
                                           APPLICATION NO. DATE
PΙ
     US 2003091798
                     A1 20030515
                                           US 2002-207698 20020729
PRAI US 2001-345404P P 20011109
     The invention relates to the design of a layered thin-film media having
     good perpendicular magnetic anisotropy suitable for
     perpendicular magnetic recording. The
     magnetic recording medium includes a tantalum seed layer
     and a ruthenium underlayer. The magnetic recording
     layer is fabricated from cobalt alloys. With the Ta seed layer, the
     perpendicular anisotropy and c-axis orientation of the
     magnetic recording layer are greatly enhanced. Unity
     squareness is achievable as is a neg. nucleation field.
     magnetic recording medium is formed by sputtering the
     various layers onto a substrate. Thus, a perpendicular
     magnetic recording medium suitable for mass prodn. is
     provided.
ST
     layered thin film media perpendicular magnetic
     recording
     Glass substrates
IT
     Lubricants
     Magnetic films
       Magnetic recording materials
        (design of a layered thin-film media for perpendicular
       magnetic recording)
ΙT
     Metals, uses
     RL: TEM (Technical or engineered material use); USES (Uses)
        (magnetic recording layer; design of a layered
        thin-film media for perpendicular magnetic
        recording)
IT
     Magnetic materials
        (soft; design of a layered thin-film media for perpendicular
        magnetic recording)
IT
     Cobalt alloy, nonbase
     RL: TEM (Technical or engineered material use); USES (Uses)
        (magnetic recording layer; design of a layered
        thin-film media for perpendicular magnetic
        recording)
ΙT
     12035-46-0, Nickel phosphide (NiP)
     RL: TEM (Technical or engineered material use); USES (Uses)
        (Al substrate coating; design of a layered thin-film media for
        perpendicular magnetic recording)
```

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168041-18-7
                                            518991-80-5 518991-81-6
IT
     11114-92-4
                  91033-96-4
     RL: TEM (Technical or engineered material use); USES (Uses)
        (magnetic recording layer; design of a layered
        thin-film media for perpendicular magnetic
        recording)
IT
     7440-44-0, Carbon, uses
     RL: TEM (Technical or engineered material use); USES (Uses)
        (protective layer; design of a layered thin-film media for
       perpendicular magnetic recording)
IT
     7440-25-7, Tantalum, uses
     RL: TEM (Technical or engineered material use); USES (Uses)
        (seed layer; design of a layered thin-film media for
       perpendicular magnetic recording)
IT
     11148-32-6
                 93511-57-0
     RL: TEM (Technical or engineered material use); USES (Uses)
        (soft magnetic layer; design of a layered thin-film media for
       perpendicular magnetic recording)
ΤТ
     7429-90-5, Aluminum, uses
     RL: TEM (Technical or engineered material use); USES (Uses)
        (substrate; design of a layered thin-film media for
       perpendicular magnetic recording)
     7440-18-8, Ruthenium, uses
IT
     RL: TEM (Technical or engineered material use); USES (Uses)
        (underlayer; design of a layered thin-film media for
        perpendicular magnetic recording)
     ANSWER 3 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
L7
     2003:241841 CAPLUS
AN
DN
     138:247487
ΤI
    Magnetic recording medium, method of manufacture
     therefor, and magnetic read/write apparatus
     Shimizu, Kenji; Sakawaki, Akira; Yang, Hui; Mochizuki, Hiro; Sakai,
IN
     Hiroshi; Hikosaka, Takashi; Oikawa, Soichi
     Showa Denko K. K., Japan; Toshiba Corporation
PA
    U.S. Pat. Appl. Publ., 21 pp.
SO
     CODEN: USXXCO
DT
     Patent
LA
    English
IC
     ICM G11B005-66
     428694000TM; 428694000R; 428694000TS; 428694000BS
NCL
CC
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56
FAN.CNT 1
     PATENT NO.
                     KIND DATE
                                         APPLICATION NO. DATE
     -----
                                          -----
                     A1 20030327
PΙ
    US 2003059651
                                         US 2002-242446
                                                           20020913
     JP 2003091811
                      A2
                           20030328
                                          JP 2001-282432 20010917
PRAI JP 2001-282432
                     Α
                           20010917
    US 2001-324532P P
                           20010926
    A magnetic recording medium having excellent magnetic
AΒ
     read/write characteristics and thermal stability characteristics, and a
     method of manufg. therefor, and a magnetic read/write app. are provided.
     This magnetic recording medium comprises an
     orientation control film that controls the orientation of a film provided
     directly above it, a perpendicular magnetic film, of which the
     axis of easy magnetization is generally oriented perpendicular
     to a substrate, and a protective film, that are provided on a non-magnetic
     substrate, in which the orientation control film is made of a non-magnetic
     material which contains 33-80 at.% of Ni and at least one element selected
     from Sc, Y, Ti, Zr, Hf, Nb and Ta.
ST
    magnetic recording material film
    Magnetic films
IT
      Magnetic recording materials
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(magnetic recording medium, method of manuf.

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therefor, and magnetic read/write app.)
IT
     Magnetic materials
        (soft; magnetic recording medium, method of manuf.
        therefor, and magnetic read/write app.)
     421550-28-9, Boron 5, chromium 30, cobalt 65 (atomic)
IT
     RL: TEM (Technical or engineered material use); USES (Uses)
        (intermediate film; magnetic recording medium,
        method of manuf. therefor, and magnetic read/write app.)
     7440-32-6, Titanium, uses 7440-44-0, Carbon, uses 12683-48-6
IT
     53550-38-2, Nickel 50, yttrium 50 (atomic) 55267-07-7, Nickel, zirconium
     56293-91-5
                  56293-97-1
                             83804-69-7, Nickel 55, niobium 45 (atomic)
     90066-56-1, Nickel 65, titanium 35 (atomic) 91791-51-4, Nickel 60,
     tantalum 40 (atomic) 99837-27-1, Hafnium 40, nickel 60 (atomic)
     110803-39-9, Nickel 75, zirconium 25 (atomic) 148296-10-0
                                                                   155885-61-3,
     Nickel 25, tantalum 75 (atomic)
                                     381242-90-6
                                                  412942-25-7, Cobalt 40,
     ruthenium 60 (atomic)
                            501380-58-1 501380-59-2 501380-60-5
     501380-61-6
                   501380-62-7
                                 501380-63-8
                                               501380-64-9
                                                             501380-65-0
     501380-66-1
                   501380-67-2
                                 501380-68-3
                                               501380-69-4
     RL: TEM (Technical or engineered material use); USES (Uses)
        (orientation control film; magnetic recording
        medium, method of manuf. therefor, and magnetic read/write app.)
IT
     11122-26-2
                  12678-40-9, Aluminum iron oxide 93844-66-7 94470-28-7,
     Cobalt 60, ruthenium 40 (atomic)
                                      104193-19-3, Cobalt 89, niobium 7,
     zirconium 4 (atomic)
                           149344-82-1 497946-26-6, Chromium 30, cobalt 65,
     platinum 5 (atomic)
                          497946-27-7, Boron 8, chromium 28, cobalt 54,
     platinum 10 (atomic) 497946-28-8, Boron 45, cobalt 55 (atomic)
     RL: TEM (Technical or engineered material use); USES (Uses)
        (soft undercoat layer; magnetic recording medium,
        method of manuf. therefor, and magnetic read/write app.)
L7
     ANSWER 4 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
     2003:154719 CAPLUS
AN
DN
     138:197650
     Magnetic recording medium, its manufacturing method,
TI
     and magnetic recording/reproducing apparatus
IN
     Shimizu, Kenji; Sakawaki, Akira; Yang, Hui; Mochizuki, Hiro; Sakai,
     Hiroshi; Hikosaka, Takashi; Nakamura, Futoshi
     Showa Denko K.K., Japan; Toshiba Corporation
PA
SO
     PCT Int. Appl., 42 pp.
     CODEN: PIXXD2
DT
     Patent
LA
     Japanese
IC
     ICM G11B005-65
     ICS G11B005-667; G11B005-66; G11B005-738
     77-8 (Magnetic Phenomena)
CC
FAN.CNT 1
     PATENT NO.
                      KIND DATE
                                           APPLICATION NO. DATE
     ------
                      ----
_{
m PI}
     WO 2003017258
                      A1
                            20030227
                                           WO 2002-JP8321
                                                            20020816
        W: SG
     JP 2003059024
                      A2
                            20030228
                                           JP 2001-247825
                                                            20010817
     US 2003104250
                      A1
                            20030605
                                           US 2002-218570
                                                            20020815
PRAI JP 2001-247825
                      Α
                            20010817
     US 2001-314669P P
                            20010827
AB
     A magnetic recording medium comprises an orientation
     control film for controlling the orientation of the film right above the
     orientation control film, a vertical magnetic film where the
     easy-magnetizing axis is largely oriented vertically with respect to the
     substrate, and a protective film all being formed on a nonmagnetic
     substrate, wherein the vertical magnetic film is made of a
     material contg. Co, Cr, Pt, Cu, the content of the Cr ranges from 16 at.%
     to 24 at.%, the content of the Cu ranges from 0.1 at.% to 4 at.%, the
     coercive force Hc of the vertical magnetic film is 3,000 (Oe) or
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greater, the reverse magnetic domain nucleus producing magnetic field

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magnetization (Mr) to the satd. magnetization (Mr) is >0.85.
     magnetic recording medium reproducing app
st
IT
     Magnetic films
       Magnetic recording materials
        (manuf. of magnetic recording media, and magnetic
        record reproducing app.)
     Magnetization
IT
        (vertical; of magnetic films in manuf. of magnetic
        recording media, and magnetic record reproducing app.)
     265990-32-7
IT
     RL: DEV (Device component use); USES (Uses)
        (base film; formation of vertical magnetic films in manuf. of
        magnetic recording media, and magnetic record
        reproducing app.)
     497946-13-1, Chromium 22, cobalt 59, copper 2, platinum 17 (atomic)
TT
     497946-14-2, Chromium 22, cobalt 60.8, copper 0.2, platinum 17 (atomic)
     497946-15-3, Chromium 22, cobalt 58.2, copper 2.8, platinum 17 (atomic)
     497946-16-4, Chromium 22, cobalt 57.2, copper 3.8, platinum 17 (atomic)
     497946-17-5, Chromium 24, cobalt 55, copper 2, platinum 17 (atomic)
     497946-19-7, Chromium 17, cobalt 64, copper 2, platinum 17 (atomic)
     497946-20-0, Boron 2, chromium 21, cobalt 58, copper 2, platinum 17
               497946-21-1, Boron 3.5, chromium 21, cobalt 56.5, copper 2,
                           497946-22-2, Chromium 21, cobalt 58, copper 2,
     platinum 17 (atomic)
                                       497946-23-3, Barium 1, chromium 21,
     platinum 17, tantalum 2 (atomic)
     cobalt 58, copper 2, platinum 17, tantalum 1 (atomic)
                                                             497946-24-4,
     Chromium 21, cobalt 63, copper 2, platinum 15 (atomic)
                                                              497946-25-5,
     Chromium 21, cobalt 54, copper 2, platinum 23 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (formation of vertical magnetic films in manuf. of
        magnetic recording media, and magnetic record
        reproducing app.)
IT
     11134-20-6, Cobalt 84, samarium 16 (atomic)
                                                   497946-29-9, Chromium 20,
     cobalt 64, copper 2, platinum 14 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (hard magnetic film; formation of vertical magnetic films in
        manuf. of magnetic recording media, and magnetic
        record reproducing app.)
     94470-28-7, Cobalt 60, ruthenium 40 (atomic) 421550-28-9, Boron
     5, chromium 30, cobalt 65 (atomic)
                                        497946-26-6, Chromium 30, cobalt 65,
     platinum 5 (atomic)
                          497946-27-7, Boron 8, chromium 28, cobalt 54,
     platinum 10 (atomic)
                          497946-28-8, Boron 45, cobalt 55 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (intermediate film; formation of vertical magnetic films in
        manuf. of magnetic recording media, and magnetic
        record reproducing app.)
IT
     7440-05-3, Palladium, uses
                                  7440-18-8, Ruthenium, uses
                                                               7440-58-6,
     Hafnium, uses
                    11099-25-5
                                  55891-00-4
                                               59124-09-3
     RL: DEV (Device component use); USES (Uses)
        (orientation control film; formation of vertical magnetic
        films in manuf. of magnetic recording media, and
        magnetic record reproducing app.)
IT
     7782-44-7, Oxygen, reactions
     RL: RCT (Reactant); RACT (Reactant or reagent)
        (oxidn. of soft magentic base films and formation of vertical
        magnetic films in manuf. of magnetic recording
        media, and magnetic record reproducing app.)
IT
     104193-19-3, Cobalt 89, niobium 7, zirconium 4 (atomic)
                                                               497946-30-2,
     Boron 2, chromium 20, cobalt 63, platinum 15 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (soft magnetic base film; formation of vertical magnetic
        films in manuf. of magnetic recording media, and
        magnetic record reproducing app.)
              THERE ARE 11 CITED REFERENCES AVAILABLE FOR THIS RECORD
RE.CNT
```

(-Hn) ranges from 0 (Oe) to 2,500 (Oe), the ratio Mr/Ms of the residual

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RE
(1) Fuji Electric Co Ltd; JP 08-77544 A 1996 CAPLUS
(2) Fuji Electric Co Ltd; JP 2001167423 A 2001 CAPLUS
(3) Fujitsu Ltd; JP 06-103554 A 1994
(4) Fujitsu Ltd; JP 06-180834 A 1994
(5) Hitachi Metals Ltd; JP 200198360 A 2001
(6) Intametarikkusu Kabushiki Kaisha Kubota Corp, JP 06-215941 A 1994 CAPLUS
(7) Kubota Corp; JP 08-31638 A 1996 CAPLUS
(8) Showa Denko Kabushiki Kaisha; JP 11-283227 A 1999
(9) Showa Denko Kabushiki Kaisha; JP 2001101643 A 2001 CAPLUS
(10) Suwa Seikosha Kabushiki Kaisha; JP 59-61012 A 1984 CAPLUS
(11) Toshiba Corp; JP 06-28652 A 1994
L7
     ANSWER 5 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
AN
     2002:927036 CAPLUS
DN
     138:10785
TI
     Perpendicular magnetic recording medium, its
     preparation, and magnetic recording/reading apparatus
     employing same
     Shimizu, Kenji; Sakawaki, Akira; Sakai, Hiroshi; Nakamura, Futoshi;
IN
     Hikosaka, Kazushi
PΑ
     Showa Denko K. K., Japan; Toshiba Corp.
     Jpn. Kokai Tokkyo Koho, 14 pp.
SO
     CODEN: JKXXAF
DT
     Patent
LA
     Japanese
     ICM G11B005-667
IC
     ICS G11B005-65; G11B005-66; G11B005-738; G11B005-851
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56
FAN.CNT 1
                      KIND DATE
     PATENT NO.
                                           APPLICATION NO. DATE
                      _ _ _ _
                           -----
PΙ
     JP 2002352409
                      A2
                            20021206
                                           JP 2001-154449
                                                            20010523
     US 2003017370
                      A1
                            20030123
                                           US 2002-151896
                                                            20020522
PRAI JP 2001-154449
                       A
                            20010523
     US 2001-295819P P
                            20010606
AB
     The magnetic recording medium comprises, on a
     nonmagnetic substrate, a soft magnetic undercoat film, a magnetic
     orientation-controlling film, a perpendicular magnetic film, and
     a protective; wherein an in-plane magnetization undercoat film made of Cr
     (alloy) and a in-plane hard magnetization film made of a Co-Cr-Pt-X alloy
     (X = B, Ta, Cu, Zr, Nb, Re, Ni, Mn, ge, Si, O, N) are arranged between the
     substrate and the soft magnetic undercoat film. The presence of in-plane
     magnetization undercoat film prevents generation of noises derived from
     the hard magnetization film.
ST
     perpendicular magnetic recording medium
     inplane magnetization undercoat chromium
IT
     Magnetic materials
        (in-plane hard magnetization film; prepn. of perpendicular
        magnetic recording medium contg. in-plane
        magnetization hard film and in-plane magnetization undercoat film)
IT
     Magnetic memory devices
        (prepn. of perpendicular magnetic recording
        medium contg. in-plane magnetization hard film and in-plane
        magnetization undercoat film)
TT
     476615-96-0, Boron 5, chromium 22, cobalt 61, platinum 12
     476615-97-1, Boron 5, chromium 18, cobalt 69, platinum 8
     476615-98-2, Chromium 21, cobalt 66, platinum 10, tantalum 3
     476615-99-3, Boron 3, chromium 20, cobalt 66, copper 3, platinum 8
     476616-00-9, Chromium 14, cobalt 76, platinum 8, tantalum 2
     Chromium 10, cobalt 78, platinum 10, tantalum 2 476616-02-1,
     Boron 4, chromium 25, cobalt 59, platinum 12 476616-03-2, Boron
     4, chromium 24, cobalt 59, platinum 13
```

RL: TEM (Technical or engineered material use); USES (Uses) (in-plane hard magnetization film; prepn. of perpendicular magnetic recording medium contg. in-plane magnetization hard film and in-plane magnetization undercoat film) 265990-32-7, Chromium 94, molybdenum 6 7440-47-3, Chromium, uses IT (atomic) RL: TEM (Technical or engineered material use); USES (Uses) (in-plane magnetization undercoat film; prepn. of perpendicular magnetic recording medium contg. in-plane magnetization hard film and in-plane magnetization undercoat film) ANSWER 6 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN L7 ΑN 2002:833344 CAPLUS DN 137:332330 TI Magnetic recording medium, method of manufacture therefor, and apparatus for magnetic reproducing and reproducing Shimizu, Kenji; Sakawaki, Akira; Sakai, Hiroshi; Hikosaka, Takashi; IN Oikawa, Soichi PA Showa Denko K.K., Kabushiki Kaisha Toshiba, Japan U.S. Pat. Appl. Publ., 14 pp. SO CODEN: USXXCO DTPatent English LAIC ICM G11B005-66 NCL 428694000TM 77-8 (Magnetic Phenomena) CC FAN.CNT 1 PATENT NO. KIND DATE APPLICATION NO. DATE ---------______ PΙ US 2002160232 A1 20021031 US 2002-82201 20020226 A2 20021213 JP 2002-55042 20020228 JP 2002358615 A 20010228 PRAI JP 2001-55950 US 2001-275102P P 20010313 A magnetic recording medium comprising: on a AB nonmagnetic substrate, at least a soft magnetic undercoat film comprising a soft magnetic material; an orientation control film for controlling an orientation of a film directly above; a perpendicular magnetic film in which an axis of easy magnetization is oriented mainly perpendicularly with respect to the substrate; and a protection film, wherein the perpendicular magnetic film has a structure in which a large no. of magnetic grains are sepd. by a grain boundary layer, and an av. sepq. distance between the magnetic grains along a straight line which connects centers of gravity of mutually neighboring magnetic grains is 1 nm or greater. perpendicular recording film easy magnetization axis orientation ST control Coercive force (magnetic) IT Grain boundaries Magnetic recording materials Magnetization (orientation control of magnetic recording medium for perpendicular recording with easy magnetization axis and grain boundary layer) IT Magnetic recording (perpendicular; orientation control of magnetic recording medium for perpendicular recording with easy magnetization axis and grain boundary layer) 7440-47-3P, Chromium, properties 7440-48-4P, Cobalt, properties IT RL: DEV (Device component use); PNU (Preparation, unclassified); PRP (Properties); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (grain boundary; orientation control of magnetic recording medium for perpendicular recording with

```
easy magnetization axis and grain boundary layer)
IT
     473740-47-5P, Chromium 35, cobalt 57, platinum 8 (atomic)
                                                                  473740-48-6P,
     Chromium 35, cobalt 51, molybdenum 6, platinum 8 (atomic)
                                                                  473740-49-7P,
     Chromium 36, cobalt 51, platinum 8, vanadium 5 (atomic)
                                                                473740-50-0P,
                                                              473740-51-1P,
     Chromium 34, cobalt 51, copper 7, platinum 8 (atomic)
     Chromium 35, cobalt 52, platinum 8, tungsten 5 (atomic)
                                                                473740-52-2P,
     Chromium 37, cobalt 48, platinum 6, rhenium 9 (atomic)
                                                               473740-53-3P,
     Chromium 36, cobalt 53, platinum 7, zirconium 4 (atomic)
                                                                 473740-54-4P,
     Chromium 29, cobalt 60, platinum 7, zirconium 4 (atomic)
                                                                 473740-55-5P,
     Chromium 43, cobalt 48, platinum 5, zirconium 4 (atomic)
                                                                 473740-56-6P,
     Chromium 47, cobalt 44, platinum 5, zirconium 4 (atomic)
                                                                 473740-57-7P,
     Chromium 35, cobalt 51, platinum 8, tantalum 6 (atomic)
                                                                473740-58-8P,
     Chromium 35, cobalt 53, platinum 8, ruthenium 4 (atomic)
     473740-59-9P, Boron 7, chromium 37, cobalt 53, platinum 3 (atomic)
     473740-60-2P, Boron 7, chromium 37, cobalt 51, platinum 5 (atomic)
     473740-61-3P, Boron 7, chromium 37, cobalt 48, platinum 8 (atomic)
     473740-62-4P, Boron 7, chromium 37, cobalt 42, platinum 14 (atomic)
     473740-63-5P, Boron 7, chromium 37, cobalt 38, platinum 18 (atomic)
     473740-64-6P, Chromium 37, cobalt 50, hafnium 5, platinum 8 (atomic)
     RL: DEV (Device component use); PNU (Preparation, unclassified); PRP
     (Properties); TEM (Technical or engineered material use); PREP
     (Preparation); USES (Uses)
        (non-magnetic intermediate; orientation control of magnetic
        recording medium for perpendicular recording with
        easy magnetization axis and grain boundary layer)
IT
     146241-23-8P, Chromium 18, cobalt 70, platinum 12 (atomic)
                                                                   473740-19-1P,
     Chromium 20, cobalt 65, platinum 15 (atomic)
                                                   473740-20-4P, Chromium 12,
     cobalt 73, platinum 15 (atomic)
                                      473740-21-5P, Chromium 24, cobalt 58,
                            473740-22-6P, Chromium 20, cobalt 60, molybdenum 5,
     platinum 18 (atomic)
     platinum 15 (atomic)
                            473740-23-7P, Chromium 20, cobalt 57, platinum 15,
     vanadium 8 (atomic)
                           473740-24-8P, Chromium 20, cobalt 61, copper 4,
     platinum 15 (atomic)
                            473740-25-9P, Chromium 20, cobalt 55, platinum 15,
     tungsten 10 (atomic)
                            473740-26-0P, Chromium 20, cobalt 58, platinum 15,
     rhenium 7 (atomic)
                          473740-27-1P, Chromium 20, cobalt 62, platinum 15,
     zirconium 3 (atomic)
                            473740-28-2P, Boron 6, chromium 20, cobalt 59,
     platinum 15 (atomic)
                            473740-29-3P, Chromium 20, cobalt 61, platinum 15,
                           473740-30-6P, Chromium 20, cobalt 53, platinum 15,
     tantalum 4 (atomic)
     ruthenium 12 (atomic)
                             473740-31-7P, Chromium 20, cobalt 59, hafnium 6,
     platinum 15 (atomic)
                            473740-32-8P, Chromium 18, cobalt 69, copper 1,
                            473740-33-9P, Chromium 18, cobalt 67, copper 3,
    platinum 12 (atomic)
                            473740-34-0P, Chromium 18, cobalt 64, copper 6,
     platinum 12 (atomic)
                            473740-35-1P, Chromium 18, cobalt 60, copper 10,
    platinum 12 (atomic)
                            473740-36-2P, Chromium 18, cobalt 56, copper 14,
    platinum 12 (atomic)
                            473740-37-3P, Chromium 18, cobalt 53, copper 17,
    platinum 12 (atomic)
                            473740-38-4P, Chromium 18, cobalt 50, copper 20,
    platinum 12 (atomic)
                            473740-39-5P, Chromium 18, cobalt 68, copper 6,
    platinum 12 (atomic)
                           473740-40-8P, Chromium 18, cobalt 56, copper 6,
    platinum 8 (atomic)
                            473740-41-9P, Chromium 18, cobalt 53, copper 6,
    platinum 20 (atomic)
                            473740-42-0P, Chromium 10, cobalt 72, copper 6,
     platinum 23 (atomic)
                            473740-43-1P, Chromium 14, cobalt 68, copper 6,
     platinum 12 (atomic)
                            473740-44-2P, Chromium 26, cobalt 56, copper 6,
     platinum 12 (atomic)
                            473740-45-3P, Chromium 30, cobalt 52, copper 6,
     platinum 12 (atomic)
     platinum 12 (atomic)
                            473740-46-4P, Chromium 30, cobalt 48, copper 10,
     platinum 12 (atomic)
     RL: DEV (Device component use); PNU (Preparation, unclassified); PRP
     (Properties); TEM (Technical or engineered material use); PREP
     (Preparation); USES (Uses)
        (perpendicular layer; orientation control of magnetic
        recording medium for perpendicular recording with
        easy magnetization axis and grain boundary layer)
     ANSWER 7 OF 7 CAPLUS COPYRIGHT 2003 ACS on STN
L7
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2002:486347 CAPLUS AN

DN 137:56379

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Magnetic recording medium and its use in
ΤI
    magnetic recording apparatus
IN
     Okijima, Makoto
    Mitsubishi Chemical Corp., Japan
PA
     Jpn. Kokai Tokkyo Koho, 6 pp.
SO
     CODEN: JKXXAF
DT
     Patent
LA.
     Japanese
     ICM G11B005-673
IC
     ICS H01F010-16; H01F010-30
     77-8 (Magnetic Phenomena)
CC
     Section cross-reference(s): 56
FAN.CNT 1
     PATENT NO.
                     KIND DATE
                                          APPLICATION NO. DATE
                                           _____
     ______
                      ____
                           _____
                                                           _____
     JP 2002183928
                      A2
                           20020628
                                          JP 2000-378224
                                                           20001213
PRAI JP 2000-378224
                           20001213
     The medium has a nonmagnetic substrate and multilayer magnetic films in
     which (1) Co alloy layers and (2) Pt or Pd-based layers are alternately
     laminated to satisfy defined decline at M = 0 in M-H curve showing
     magnetic characteristics in vertical direction to the multilayer
     films. The medium has high coercive force and S/N ratio and gives app.
     with high d. and low noise.
ST
    magnetic recording medium multilayer film cobalt
     alloy; platinum multilayer film magnetic recording
     medium; palladium multilayer film magnetic recording
     medium
IT
     Magnetic memory devices
      Magnetic recording materials
        (magnetic recording medium with multilayer films
        and its use in magnetic recording app.)
     7440-05-3, Palladium, uses 7440-06-4, Platinum, uses
                                                              96698-73-6
IT
     438566-65-5, Boron 9, chromium 15, cobalt 76 (atomic)
     RL: TEM (Technical or engineered material use); USES (Uses)
        (film; magnetic recording medium with multilayer
        films and its use in magnetic recording app.)
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=> d hist

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L9
    ANSWER 1 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
    2003:433030 CAPLUS
AN
DN
    139:16452
    Magnetic recording medium and magnetic
ΤI
    recording apparatus using it
    Kamibe, Tetsuya; Yaku, Hiroo; Suzuki, Hiroyuki; Kashiwase, Eiichi
IN
    Hitachi Ltd., Japan
PΑ
    Jpn. Kokai Tokkyo Koho, 11 pp.
SO
    CODEN: JKXXAF
DT
    Patent
    Japanese
LA
    ICM G11B005-738
IC
    ICS G11B005-64; G11B005-65; G11B005-66
CC
    77-8 (Magnetic Phenomena)
    Section cross-reference(s): 56
FAN. CNT 1
    PATENT NO.
                     KIND DATE
                                          APPLICATION NO. DATE
     ______
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                                          _____
                                                          ______
    JP 2003162813
                      A2
                           20030606
                                          JP 2001-361909
                                                          20011128
    US 2003138665
                     A1
                           20030724
                                          US 2002-306361 20021127
PRAI JP 2001-361909
                     Α
                           20011128
    The recording medium has (1) a multilayered underlayer including a layer
    of a Cr alloy contg. 2-12 at. B and having body-centered cubic structure,
     (2) a lower magnetic layer of a Co alloy contg. 10-16 at.% Cr having
    thickness 1.5-4.5 nm, (3) a nonmagnetic middle layer, and (4) a Co-based
    upper magnetic layer having antiferromagnetic coupling with the lower
    magnetic layer, which are formed in this order on a nonmagnetic substrate.
    The lower magnetic layer may contain .ltoreq.10 at. % Pt. The recording
    medium has high medium S/N, thermal stability, and in-plane recording d.
     (.qtoreq.50 Mbit/mm2). Also claimed is a magnetic
    recording app. equipped with the recording medium and a composite
    magnetic head having an electromagnetic induction-type recording head and
    a spin valve-type reproducing head.
    magnetic recording medium low noise thermal stability;
ST
    composite head magnetic recording app
IT
    Magnetic disks
    Magnetic memory devices
        (magnetic recording medium with high medium S/N,
        thermal stability, and in-plane recording d. and magnetic
        recording app. using it)
    85424-54-0, Chromium 14, cobalt 86 (atomic) 129516-30-9, Chromium 12,
TT
    cobalt 82, platinum 6 (atomic) 129617-87-4, Chromium 16, cobalt 80,
                         174528-04-2, Chromium 14, cobalt 82, platinum 4
    platinum 4 (atomic)
              202754-39-0, Chromium 14, cobalt 78, platinum 8 (atomic)
    443913-81-3, Chromium 16, cobalt 76, platinum 8 (atomic)
                                                             534600-36-7,
    Chromium 14, cobalt 76, platinum 10 (atomic)
                                                   534600-37-8, Chromium 14,
                                    534600-38-9, Chromium 10, cobalt 88,
    cobalt 80, platinum 6 (atomic)
    platinum 2 (atomic)
                        534600-39-0, Chromium 12, cobalt 84, platinum 4
     (atomic) 534600-40-3, Boron 5, chromium 14, cobalt 81 (atomic)
     534600-41-4, Boron 10, chromium 13.5, cobalt 76.5 (atomic)
     534600-42-5, Boron 6, chromium 12, cobalt 78, platinum 4 (atomic)
     534600-43-6, Chromium 14, cobalt 81, ruthenium 5 (atomic)
    Boron 3, chromium 14, cobalt 78, ruthenium 5 (atomic) 534600-45-8,
     Chromium 13, cobalt 79, rhenium 8 (atomic)
                                                 534600-46-9, Boron 4,
     chromium 13, cobalt 75, rhenium 8 (atomic)
                                                 534600-47-0, Chromium 10-16,
     cobalt bal. (atomic)
                          534600-48-1
    RL: DEV (Device component use); TEM (Technical or engineered material
     use); USES (Uses)
        (lower magnetic layer; magnetic recording medium
        with high medium S/N, thermal stability, and in-plane recording d. and
       magnetic recording app. using it)
     7440-18-8, Ruthenium, uses
IT
     RL: DEV (Device component use); TEM (Technical or engineered material
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use); USES (Uses)
        (nonmagnetic middle layer; magnetic recording
        medium with high medium S/N, thermal stability, and in-plane recording
        d. and magnetic recording app. using it)
                                12780-63-1, Aluminum 50, nickel 50 (atomic)
     7440-47-3, Chromium, uses
IT
     59913-35-8, Nickel 50, niobium 50 (atomic) 91791-51-4, Nickel 60,
     tantalum 40 (atomic) 94470-28-7, Cobalt 60, ruthenium 40 (atomic)
     147856-89-1, Chromium 36, cobalt 64 (atomic) 207224-38-2, Boron 5,
     chromium 80, titanium 15 (atomic) 447414-43-9, Boron 3, chromium 77,
     titanium 20 (atomic) 534600-49-2, Boron 7, chromium 83, tungsten 10
               534600-50-5, Boron 3, chromium 77, molybdenum 10, titanium 10
     (atomic)
               534600-51-6, Boron 83, chromium 15, titanium 2 (atomic)
     534600-52-7, Boron 83, chromium 10, titanium 7 (atomic)
                                                              534600-53-8,
     Boron 80.5, chromium 7.5, titanium 12 (atomic)
                                                     534600-54-9, Boron 2-12,
     chromium 88-98 (atomic)
     RL: DEV (Device component use); TEM (Technical or engineered material
     use); USES (Uses)
        (underlayer; magnetic recording medium with high
        medium S/N, thermal stability, and in-plane recording d. and
       magnetic recording app. using it)
     412942-37-1, Boron 8, chromium 18, cobalt bal., platinum 14 (atomic)
     473710-96-2, Boron 8, chromium 18, cobalt bal., platinum 12 (atomic)
     502084-07-3, Boron 6, chromium 18, cobalt 60, copper 2, platinum 14
               534600-55-0, Boron 6, chromium 16, cobalt 66, copper 2,
     platinum 10 (atomic)
     RL: DEV (Device component use); TEM (Technical or engineered material
     use); USES (Uses)
        (upper magnetic layer; magnetic recording medium
        with high medium S/N, thermal stability, and in-plane recording d. and
       magnetic recording app. using it)
     ANSWER 2 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
     2002:539349 CAPLUS
DN
     137:102834
     Magnetic recording media, their manufacturing method
ΤI
     and apparatus, and magnetic record players
IN
     Sakawaki, Akira; Kokubu, Makoto; Sakai, Hiroshi
PA
     Showa Denko K. K., Japan
SO
     Jpn. Kokai Tokkyo Koho, 17 pp.
     CODEN: JKXXAF
DT
     Patent
LA
     Japanese
IC
     ICM G11B005-738
         G11B005-64; G11B005-65; G11B005-851; H01F010-13; H01F010-16;
         H01F010-30; H01F041-14
CC
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 75
FAN.CNT 1
                                         APPLICATION NO. DATE
     PATENT NO.
                    KIND DATE
     ----- ---- ---- -----
                                          ______
     JP 2002203312 A2 20020719
                                          JP 2001-260383 20010829
PΙ
PRAI JP 2000-259871 A
JP 2000-335021 A
                           20000829
                           20001101
     Magnetic recording media contain: nonmetal substrates;
AB
     nonmagnetic base films having bcc structure; orientation adjustment films
     between the substrates and the base films, which have columnar fine
     crystal grains inclined in radial direction, and orient the base film in
     (2 0 0) plane; and magnetic films which have hcp structure and are
     oriented in (1 0 0) plane. Coercive force ratio Hcc/Hcr is >1, where the
     Hcc and Hcr are coercive force in, resp., circumferential and radial
     direction. The magnetic recording media have
     excellent magnetic characteristic and can be manufd. with ease. Manufg.
     method and app. of the magnetic recording media, as
     well as magnetic record players are also described.
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ST
     magnetic recording media manufg app; player magnetic
     record coercive force
     Coercive force (magnetic)
TΤ
     Crystal orientation
        (in magnetic recording media, their manufg. method
        and app., and magnetic record players)
    Magnetic recording materials
IT
        (magnetic recording media, their manufg. method and
        app., and magnetic record players)
     7439-98-7, Molybdenum, uses 7440-03-1, Niobium, uses
                                                              7440-25-7,
IT
                     7440-33-7, Tungsten, uses
                                                7440-47-3, Chromium, uses
     Tantalum, uses
                                 11146-56-8, Nickel 75, phosphorus 25 (atomic)
     7440-62-2, Vanadium, uses
     12639-53-1, Aluminum 50, cobalt 50 (atomic)
                                                  12707-14-1, Aluminum 50,
     iron 50 (atomic)
                      12778-98-2, Palladium 80, silicon 20 (atomic)
     12780-63-1, Aluminum 50, nickel 50 (atomic) 37219-42-4, Iron 50, niobium
     50 (atomic)
                  37270-13-6, Nickel 80, phosphorus 20 (atomic) 37373-03-8,
     Chromium 80, molybdenum 20 (atomic)
                                         54801-24-0, Chromium 64, titanium 36
                56273-68-8, Copper 57, zirconium 43 (atomic)
                                                              59913-25-6,
     Nickel 50, tantalum 50 (atomic)
                                      59913-35-8, Nickel 50, niobium 50
                61590-11-2, Copper 50, titanium 50 (atomic)
                                                              73530-96-8,
     Nickel 70, tantalum 30 (atomic)
                                     77506-62-8, Cobalt 50, tantalum 50
                77840-99-4, Chromium 45, titanium 55 (atomic)
                                                                78391-77-2,
     Nickel 75, niobium 25 (atomic)
                                    85423-64-9, Aluminum 15, chromium 85
               86313-96-4, Carbon 5, chromium 95 (atomic)
                                                             87646-30-8,
     Aluminum 67, yttrium 33 (atomic)
                                       103299-67-8, Cobalt 70, niobium 30
               106642-90-4, Cobalt 80, zirconium 20 (atomic)
                                                              110431-79-3,
     (atomic)
     Chromium 70, titanium 30 (atomic)
                                        111894-30-5, Nickel 67, phosphorus 33
               122844-03-5, Chromium 90, ruthenium 10 (atomic)
     (atomic)
                                                                124798-72-7,
     Chromium 85, vanadium 15 (atomic)
                                        124849-54-3, Cobalt 75, niobium 25
               130499-76-2, Chromium 90, oxygen 10 (atomic)
                                                              134737-83-0,
     Nickel 35, tantalum 65 (atomic)
                                     142812-82-6, Chromium 70, niobium 30
     (atomic) 150137-07-8, Boron 20, chromium 30, cobalt 50 (atomic)
     150565-07-4, Boron 10, chromium 90 (atomic)
                                                  166522-12-9, Chromium 80,
     tungsten 20 (atomic) 174321-15-4, Chromium 85, titanium 15 (atomic)
     180272-93-9, Chromium 60, niobium 40 (atomic)
                                                   182559-96-2, Chromium 90,
     nitrogen 10 (atomic)
                          207224-28-0, Chromium 30, cobalt 60, zirconium 10
               241826-25-5, Chromium 90, tantalum 10 (atomic)
     (atomic)
                                                               251540-83-7,
     Chromium 80, niobium 20 (atomic)
                                       356056-98-9, Chromium 85, niobium 15
               414904-33-9, Cobalt 65, tantalum 35 (atomic)
                                                               414904-34-0,
     Carbon 18, chromium 26, cobalt 56 (atomic)
                                                414904-35-1, Chromium 65,
     tantalum 35 (atomic)
                           414904-36-2, Cobalt 72, tantalum 28 (atomic)
     442551-39-5, Hafnium 34, tungsten 66 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (orientation adjustment films in magnetic recording
        media, their manufg. method and app., and magnetic record players)
L9
     ANSWER 3 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
     2002:345865 CAPLUS
AN
DN
     136:362831
     Magnetic recording medium for high density recording
ΤI
     Futamoto, Masaaki; Inaba, Nobuyuki; Hirayama, Yoshiyuki; Takeuchi,
IN
     Teruaki; Honda, Yukio
PA
     Hitachi Ltd., Japan
so
     U.S., 20 pp.
     CODEN: USXXAM
DT
     Patent
LΑ
     English
IC
     ICM G11B005-66
     ICS G11B005-70
NCL
     428694000TS
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56
FAN.CNT 2
     PATENT NO.
                     KIND DATE
                                           APPLICATION NO.
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ΡI
    US 6383667
                      R1
                            20020507
                                           US 1999-413813
                                                             19991007
                          20000814
                                           JP 1998-288134
                      B2
                                                             19981009
     JP 3075712
                                                             19990224
     JP 2000251237
                      A2 20000914
                                           JP 1999-45884
                      B2
                            20010416
     JP 3157806
                      A1
     US 2002068199
                            20020606
                                           US 2001-1995
                                                             20011205
                       B2
                            20030401
     US 6541125
PRAI JP 1998-288134
                       Α
                            19981009
     JP 1999-45884
                       Α
                            19990224
                       A1
    US 1999-413813
                            19991007
    The present invention relates to a magnetic recording
AΒ
     medium that has a magnetic film suitable for high-d. magnetic
                The magnetic recording medium
     includes a substrate, an underlayer provided on the substrate, a Co alloy
     magnetic film formed through the underlayer, and a protective film for
    protecting the magnetic film, in which the underlayer has a 2-layer
     structure of an lower underlayer contacted with the substrate and an upper
     underlayer contacted with the Co alloy magnetic film, the upper underlayer
     is a Co-Crx-My alloy film having a hcp. structure, where 25 at.% .ltoreq.
     x+y .ltoreq. 50 at.%, 0.5 at.% .ltoreq.y, and non-magnetic element M is
     selected from the group of elements B, Si, Ge, C, Al, P, Ti, V, Nb, Zr,
    Hf, Mn, Rh, Os, Ir, Re, Pd, Pt, Mo, Ta, W, Ag and Au. Thereby the medium
     can be increased in its coercive force and can be improved in its thermal
     stability characteristics.
ST
     chromium cobalt alloy magnetic recording medium
IT
     Coercive force (magnetic)
     Thermal stability
        (improvement of; magnetic recording medium for high
        d. recording)
IT
    Magnetic films
      Magnetic recording materials
        (magnetic recording medium for high d. recording)
IT
    1314-23-4, Zirconia, uses
                                 7440-03-1, Niobium, uses
                                                             7440-21-3, Silicon,
           7440-32-6, Titanium, uses
                                        7440-47-3, Chromium, uses 7440-58-6,
                     7440-67-7, Zirconium, uses
                                                  7631-86-9, Silica, uses
    Hafnium, uses
     12381-52-1, Chromium silicide (CrSi3)
                                             12797-58-9
    RL: TEM (Technical or engineered material use); USES (Uses)
        (adhesion layer; magnetic recording medium for high
        d. recording)
ΙT
    197803-58-0 421550-46-1
                               421550-47-2
                                             421550-48-3
     421550-49-4
                   421550-50-7
                                 421550-51-8
                                               421550-52-9
                                                              421550-53-0
                   421550-55-2
                                 421550-56-3
     421550-54-1
                                               421550-57-4
                                                              421550-58-5
     421550-61-0
                   421550-64-3
                                 421550-67-6
                                               421550-68-7
                                                              421550-69-8
     421550-70-1
    RL: TEM (Technical or engineered material use); USES (Uses)
        (film material; magnetic recording medium for high
        d. recording)
IT
     1309-48-4, Magnesium oxide (MgO), uses
                                              7789-24-4, Lithium fluoride
                                11114-60-6
     (LiF), uses
                   11114-55-9
                                             11114-68-4
                                                          11143-56-9
     11147-86-7
                  12682-24-5
                               39286-82-3
                                            39314-47-1
                                                         39460-27-0
                  59124-11-7
                               77592-17-7, Cobalt 50, ruthenium 50 (atomic)
     94470-28-7, Cobalt 60, ruthenium 40 (atomic)
                                                    147099-05-6, Cobalt 90,
     ruthenium 10 (atomic)
                             153084-87-8
                                           160619-62-5, Cobalt 80, ruthenium 20
                273379-93-4, Cobalt 65, ruthenium 35 (atomic)
                                                                 341036-30-4
                   412942-25-7
     366476-02-0
                                 421550-72-3
                                               421550-73-4
                                                              421550-74-5
                   421550-76-7
                                 421550-77-8
     421550-75-6
                                               421550-78-9
                                                              421550-79-0
     421550-80-3
                   421550-81-4
                                 421550-82-5
                                               421550-83-6
                                                              421550-84-7
     421550-85-8
                   421550-86-9
                                 421550-87-0
                                               421550-88-1
                                                              421550-89-2
     421550-90-5
    RL: TEM (Technical or engineered material use); USES (Uses)
        (lower underlayer; magnetic recording medium for
       high d. recording)
IT
                  213332-70-8, Chromium 30, cobalt 66, titanium 4 (atomic)
     323187-06-0, Chromium 30, cobalt 60, manganese 10 (atomic)
```

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421550-32-5 421550-33-6
                                421550-34-7
                                             421550-35-8
                                                             421550-36-9
     421550-37-0 421550-39-2
                                421550-40-5
                                             421550-41-6
                                                           421550-42-7
     421550-43-8 421550-44-9
                                 421550-45-0
     RL: TEM (Technical or engineered material use); USES (Uses)
        (magnetic recording medium for high d. recording)
     294626-73-6, Boron 6, chromium 25, cobalt 69 (atomic)
IT
     294626-75-8, Chromium 25, cobalt 67, silicon 8 (atomic)
                                                               294626-77-0,
     Chromium 25, cobalt 65, germanium 10 (atomic)
                                                   294626-79-2, Aluminum 4,
     chromium 25, cobalt 71 (atomic) 294626-81-6, Chromium 25, cobalt 69,
     phosphorus 6 (atomic)
                            294626-83-8, Chromium 25, cobalt 69, titanium 6
               294626-85-0, Chromium 25, cobalt 65, vanadium 10 (atomic)
     (atomic)
     294626-87-2, Chromium 25, cobalt 71, zirconium 4 (atomic)
     Chromium 25, cobalt 67, niobium 8 (atomic) 294626-91-8, Chromium 25,
     cobalt 69, hafnium 6 (atomic)
                                     294626-93-0, Chromium 25, cobalt 65,
     manganese 10 (atomic)
                             294626-95-2, Chromium 25, cobalt 63, rhodium 12
               294626-97-4, Chromium 25, cobalt 57, iridium 18 (atomic)
     294626-99-6, Chromium 25, cobalt 61, rhenium 14 (atomic) 294627-01-3,
     Chromium 25, cobalt 67, palladium 8 (atomic)
                                                   294627-03-5, Chromium 25,
     cobalt 69, platinum 6 (atomic)
                                     294627-05-7, Chromium 25, cobalt 71,
     molybdenum 4 (atomic)
                            294627-07-9, Chromium 25, cobalt 67, tungsten 8
               294627-09-1, Chromium 25, cobalt 71, silver 4 (atomic)
     294627-11-5, Chromium 25, cobalt 69, gold 6 (atomic)
     RL: TEM (Technical or engineered material use); USES (Uses)
        (upper underlayer; magnetic recording medium for
        high d. recording)
RE.CNT
              THERE ARE 12 CITED REFERENCES AVAILABLE FOR THIS RECORD
RE
(1) Anon; JP 04321919 1992
(2) Anon; JP 07057233 1995 CAPLUS
(3) Anon; JP 10233016 1998 CAPLUS
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    CAPLUS
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L9
     ANSWER 4 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
AN
     2002:315388 CAPLUS
DN
     136:334115
     Magnetic recording medium, process and apparatus for
TI
     producing the same, and magnetic recording and
     reproducing apparatus
IN
     Sakawaki, Akira; Kokubu, Masato; Sakai, Hiroshi
PΑ
     Show A Denko K.K., Japan
SO
     U.S. Pat. Appl. Publ., 24 pp.
     CODEN: USXXCO
DT
     Patent
LΑ
     English
IC
     ICM G11B005-66
NCL
     428694000TS
     77-8 (Magnetic Phenomena)
CC
FAN.CNT 1
     PATENT NO.
                     KIND DATE
                                           APPLICATION NO. DATE
     US 2002048695
                      A1
                            20020425
                                           US 2001-940853
                                                            20010829
PRAI JP 2000-202158
                      Α
                            20000829
     US 2001-304745P P
                           20010713
     The present invention relates to a magnetic recording
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421550-30-3

421550-31-4

421550-29-0

421550-28-9

medium used in an app. such as a magnetic disk app.; a process and an app. for producing the magnetic recording medium; and a magnetic recording and reproducing app. incorporating the magnetic recording medium. A magnetic recording medium is presented which exhibits excellent magnetic characteristics and which can be easily produced. A magnetic recording medium contg. a non-metallic substrate, a non-magnetic undercoat film, a Co alloy hexagonal closed packed (hcp.) (110) textured magnetic film, and a protective film formed on the substrate. An orientation-detq. film, which dets. the crystal orientation of an undercoat film provided directly thereon to cause the texture of the undercoat film to be (200), is formed between the substrate and the undercoat film. The orientation-detg. film has a crystal structure such that columnar fine crystal grains are inclined in a radial direction of the substrate, and the ratio of a coercive force in a circumferential direction of the medium (Hcc) to a coercive force in a radial direction of the medium (Hcr); i.e., Hcc/Hcr, is >1. magnetic recording material disk app Magnetic disks Magnetic films Magnetic recording materials (materials and app. for magnetic recording disks) Chromium alloy, base Cobalt alloy, base Molybdenum alloy, base Niobium alloy, base Tantalum alloy, base Tungsten alloy, base Vanadium alloy, base RL: TEM (Technical or engineered material use); USES (Uses) (materials and app. for magnetic recording disks) 7439-98-7, Molybdenum, uses 7440-03-1, Niobium, uses 7440-25-7. 7440-33-7, Tungsten, uses 7440-47-3, Chromium, uses Tantalum, uses 7440-62-2, Vanadium, uses 11114-55-9 11114-60-6 11114-68-4 11146-56-8, Nickel 75, phosphorus 25 (atomic) 12035-64-2, Nickel phosphide (Ni2P) 12639-53-1, Aluminum 50, cobalt 50 (atomic) 12707-14-1, Aluminum 50, iron 50 (atomic) 12778-98-2, Palladium 80, silicon 20 (atomic) 12780-63-1, Aluminum 50, nickel 50 (atomic) 37219-42-4, Iron 50, niobium 50 (atomic) 37270-13-6, Nickel 32582-73-3 80, phosphorus 20 (atomic) 37373-03-8, Chromium 80, molybdenum 20 54801-24-0, Chromium 64, titanium 36 (atomic) (atomic) 55891-00-4 56273-68-8, Copper 57, zirconium 43 (atomic) 59913-25-6, Nickel 50, 59913-35-8, Nickel 50, niobium 50 (atomic) tantalum 50 (atomic) 61590-11-2, Copper 50, titanium 50 (atomic) 68394-23-0 73530-96-8, Nickel 70, tantalum 30 (atomic) 77506-62-8, Cobalt 50, tantalum 50 (atomic) 77840-99-4 78391-77-2, Nickel 75, niobium 25 79007-63-9, Cobalt 67, zirconium 33 (atomic) 85423-64-9, (atomic) Aluminum 15, chromium 85 (atomic) 86313-96-4, Carbon 5, chromium 95 87646-30-8, Aluminum 67, yttrium 33 (atomic) 103299-67-8, (atomic) 106642-90-4, Cobalt 80, zirconium 20 Cobalt 70, niobium 30 (atomic) 110431-79-3, Chromium 70, titanium 30 (atomic) (atomic) 122844-03-5, Chromium 90, ruthenium 10 (atomic) 124798-72-7, Chromium 85, vanadium 15 124849-54-3, Cobalt 75, niobium 25 (atomic) 134737-83-0, Nickel 35, tantalum 65 (atomic) 142812-82-6, Chromium 70, niobium 30 (atomic) 150137-07-8, Boron 20, chromium 30, cobalt 50 (atomic) 166522-12-9, Chromium 80, tungsten 20 (atomic) 174321-15-4, Chromium 85, titanium 15 (atomic) 180272-93-9 182559-96-2 207224-28-0, Chromium 30, cobalt 60, zirconium 10 (atomic) 241826-25-5, Chromium 90, tantalum 10 (atomic) 251540-83-7, Chromium 80, niobium 20 (atomic) 414904-33-9 414904-34-0 414904-35-1 414904-36-2

RL: TEM (Technical or engineered material use); USES (Uses) (materials and app. for magnetic recording disks)

ST

IT

ΙT

IT

L9

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AN
     2002:281325 CAPLUS
DN
     137:40593
     Thermodynamic calculations of the effect of B and Ta on magnetically
ΤI
     induced phase separation in Co-Cr-Pt alloys
     Oikawa, K.; Qin, G. W.; Okamoto, S.; Kitakami, O.; Shimada, Y.; Fukamichi,
ΑŲ
     K.; Ishida, K.
     National Institute of Advanced Industrial Science and Technology, Sendai,
CS
     983-8551, Japan
     Applied Physics Letters (2002), 80(15), 2704-2706
SO
     CODEN: APPLAB; ISSN: 0003-6951
     American Institute of Physics
PB
DT
     Journal
     English
LA
CC
     77-1 (Magnetic Phenomena)
     Section cross-reference(s): 56
AB
     To clarify the relation between the magnetically induced phase sepn. and
     the recording media characteristics, the thermodn. calcns. of Co-Cr-Pt-B
     and Co-Cr-Pt-Ta systems were carried out by the available binary
     assessment data and Miedema's semiempirical values. B is segregated to
     the boundary in a similar manner as Cr, which makes the boundary region
    paramagnetic. This result is consistent with available data that B
     weakens the intergranular magnetic coupling and increases the magnetic
     anisotropy in Co-Cr-Pt recording media. By adding Ta, the Cr content in
     the paramagnetic phase is also increased, reducing the intergranular
     magnetic coupling. However, the Ta content in the ferromagnetic phase is
    higher than in the paramagnetic phase, decreasing the magnetic anisotropy.
     Accordingly, the thermodn. calcns. successfully explain exptl. magnetic
     data for Co-Cr-Pt-B and Co-Cr-Pt-Ta recording media.
ST
     chromium cobalt platinum boron magnetic recording
     medium phase sepn; tantalum chromium cobalt platinum magnetic
     recording medium phase sepn
     Ferromagnetic materials
TΨ
     Magnetic field effects
      Magnetic recording materials
     Paramagnetic materials
     Phase separation
        (thermodn. calcns. of the effect of B and Ta on magnetically induced
       phase sepn. in Co-Cr-Pt magnetic recording media)
TΤ
     436868-27-8 436868-28-9 436868-29-0
                   436868-31-4
     436868-30-3
                                 436868-32-5
                                               436868-33-6
     436868-34-7
     RL: PEP (Physical, engineering or chemical process); PRP (Properties); PYP
     (Physical process); TEM (Technical or engineered material use); PROC
     (Process); USES (Uses)
        (thermodn. calcns. of the effect of B and Ta on magnetically induced
       phase sepn. in Co-Cr-Pt magnetic recording media)
RE.CNT
              THERE ARE 26 CITED REFERENCES AVAILABLE FOR THIS RECORD
RE
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CAPLUS
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     ANSWER 6 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
     2001:91421 CAPLUS
AN
DN
     134:140818
ΤI
    Magnetic Co-Cr-Pt-B alloys in layered structure suitable for magnetic data
     storage on hard disks
IN
     Margulies, David Thomas; Marinero, Ernesto Esteban; Rosen, Hal Jervis;
     Rubin, Kurt Alan; York, Brian Rodrick
     International Business Machines Corporation, USA
PA
     U.S., 11 pp.
SO
     CODEN: USXXAM
DT
     Patent
LA
     English
IC
     ICM G11B005-66
NCL
     428065300
     77-4 (Magnetic Phenomena)
CC
     Section cross-reference(s): 56
FAN.CNT 1
     PATENT NO.
                    KIND DATE
                                          APPLICATION NO. DATE
     ______
                                           -----
     US 6183832
                     B1 20010206
                                           US 1998-173476 19981014
PΙ
PRAI US 1998-173476
                           19981014
     The magnetic multilayer structure contains: (a) top film 10-500 .ANG.
     thick of the magnetic Co alloy contg. Cr 0-30, Pt 0-40, and B 10-25 at.%
     with Co at 40-75 at.%; (b) similar Co-alloy inter/ayer 1-100 .ANG. thick
     for nucleation control, and contg. 50-75 at.% Co/with Cr 15-40, Pt 0-15,
     and B 0-10 at.%; (c) metal or alloy interlayer film having bcc.
     crystallog. structure, esp. as Cr, Ru, or their alloys; and (d) hard-disk
     substrate, esp. Al precoated with Ni-P alloy /ayer. The magnetic layered
     structure with the nucleation alloy interlayer is suitable for the
     magnetic Co-alloy layer having coercive for \phie of 2000-5000 Oe, the grain
     size of 30-200 .ANG., and anisotropic crystallog. orientation with the
     c-axis in the layer plane. The typical nucleation interlayer is
     Co71Cr17Pt12, and increases magnetic coerdive force of the top
     Co71Cr17Pt12 B-contg. alloy layer to a max. at .apprx.12 at.% B, vs. only
     .apprx.5 at.% B without the interlayer The layered-alloy structures are suitable for magnetic disks and related data-storage devices.
ST
     magnetic disk data storage layered alloy structure; cobalt chromium
     platinum boron alloy magnetic disk
IT
     Ceramics
        (hard disk substrate, coating of; magnetic Co-Cr-Pt-B alloys with
        layered structure for data storage on hard disks)
IT
     Glass, uses
     RL: DEV (Device component use); USES (Uses)
        (hard disk substrate, coating of; magnetic Co-Cr-Pt-B alloys with
        layered structure for data storage on hard disks)
IT
     Coercive force (magnetic)
        (layered alloy structure with; magnetic Co-Cr-Pt-B alloys with layered
        structure for data storage on hard disks)
IT
     Magnetic disks
        (layered; magnetic Co-Cr-Pt-B alloys with layered structure for data
```

storage on hard disks) IT Sputtering (magnetic coating by; magnetic Co-Cr-Pt-B alloys with layered structure for data storage on hard disks) TΤ RL: DEV (Device component use); USES (Uses) (coating, hard disks with; magnetic Co-Cr-Pt-B alloys in layered coating for data storage on hard disks) IT 7440-21-3, Silicon, uses 14808-60-7, Quartz, uses RL: DEV (Device component use); USES (Uses) (hard disk substrate, magnetic coating of; magnetic Co-Cr-Pt-B alloys in layered coating for data storage on hard disks) 7429-90-5, Aluminum, uses IT RL: DEV (Device component use); USES (Uses) (hard disks; magnetic Co-Cr-Pt-B alloys in layered coating for data storage on hard disks) 7440-47-3, Chromium, uses IT 7440-18-8, Ruthenium, uses RL: TEM (Technical or engineered material use); USES (Uses) (interlayer; magnetic Co-Cr-Pt-B alloys in layered coating for data storage on hard disks) IT 130957-81-2 RL: TEM (Technical or engineered material use); USES (Uses) (interlayer; magnetic Co-Cr-Pt-B alloys with layered structure for data storage on hard disks) 7440-42-8, Boron, uses IT RL: MOA (Modifier or additive use); USES (Uses) (magnetic alloys with; magnetic Co-Cr-Pt-B alloys in layered coating for data storage on hard disks) 321993-81-1 321993-82-2 TΤ RL: TEM (Technical or engineered material use); USES (Uses) (magnetic recording with; magnetic Co-Cr-Pt-B alloys with layered structure for data storage on hard disks) RE.CNT THERE ARE 7 CITED REFERENCES AVAILABLE FOR THIS RECORD RÉ (1) Doerner; US 5523173 1996 (2) Glijer, P; Magnetic force microscopy (MFM) studies of micromagnetic structures of high coercivity CoCrPt/Cr and CoCrPtBCr thin films 1995, V31(6), P2842 CAPLUS (3) Glijer, P; Structural design of CoCrPt(Ta,B)/Cr magnetic thin film media for ultra high density longitudinal magnetic recording 1995, V33(10/11), P1575 CAPLUS (4) Murayama; US 5478661 1995 (5) Oka; US 5494722 1996 CAPLUS (6) Song, L; "Magnetic properties and recording performance of multilayer films of CoCrTa, CoCrPtTa, and CoCrPtTa with CoCrPtB 1994, V30(6), P4011 CAPLUS (7) Tani, N; "High coercivity hard disk with CoCrPtB/Cr media", IEEE 1991, V27(6), P4736 CAPLUS ANSWER 7 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN L9 AN2001:43445 CAPLUS DN 134:109514 Thin film magnetic disk having reactive element doped refractory metal ΤI seed layer Bian, Xiaoping; Duan, Shanlin; Li, Jinshan; Mirzamaani, Mohammad IN International Business Machines Corporation, USA PA U.S., 7 pp. SO CODEN: USXXAM DTPatent LA English ICM G11B005-66 IC 428065300 NCL 77-8 (Magnetic Phenomena) CC Section cross-reference(s): 56, 75

FAN.CNT 1

KIND DATE APPLICATION NO. DATE PATENT NO. -------------------B1 20010116 US 1998-20151 19980206 US 6174582 ΡI 19980206 PRAI US 1998-20151 A method of fabricating a thin film magnetic disk includes depositing a seed layer of a refractory metal such as Ta, Cr, Nb, W, V, or Mo and a reactive element such as N or O; depositing a nonmagnetic underlayer onto the seed layer; and depositing a magnetic layer. The thin film magnetic disk has a substrate; a seed layer comprising Ta and at least .apprx.1 at .- % of N or O; an underlayer comprising Cr or an alloy of Cr deposited onto the seed layer, the underlayer preferably having a preferred orientation of [200]; and a magnetic layer deposited onto the underlayer, the magnetic layer preferably having a preferred orientation of [1120]. A disk drive using the thin film magnetic disk is also presented. STfilm magnetic disk nitrogen oxygen doped metal seed layer; tantalum chromium niobium tungsten vanadium molybdenum doped seed layer IT (disk drive, rotary; thin film magnetic disk having reactive element doped refractory metal seed layer) IT Ceramics (substrate; thin film magnetic disk Maving reactive element doped refractory metal seed layer) ΙT Glass, uses RL: DEV (Device component use); USES (Uses) (substrate; thin film magnetic disk having reactive element doped refractory metal seed layer) IT Magnetic disks Magnetic films Magnetic recording heads Sputtering (thin film magnetic disk having reactive element doped refractory metal seed laver) ΙT Refractory metals RL: DEV (Device component use); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (thin film magnetic disk having reactive element doped refractory metal seed layer)--319488-78-3 Boron 2-6, chromium 18-23, cobalt 59-76, platinum IT 4-12 (atomic) 319488-79-4, Chromium 18-23, cobalt 59-76, platinum 4-12, tantalum 2-6 (atomic) RL: DEV (Device component use); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses) (magnetic layer; thin film magnetic disk having reactive element doped refractory metal seed layer) IT 7440-44-0, Carbon, processes RL: DEV (Device component use); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses) (protective overcoat; thin film magnetic disk having reactive element doped refractory metal seed layer) IT 7439-98-7, Molybdenum, processes 7440-03-1, Niobium, processes 7440-25-7, Tantalum, processes 7440-33-7, Tungsten, processes 7440-47-3, Chromium, processes 7440-62-2, Vanadium, processes RL: DEV (Device component use); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (thin film magnetic disk having reactive element doped refractory metal seed laver) 7782-44-7, Oxygen, uses IT 7727-37-9, Nitrogen, uses

(thin film magnetic disk having reactive element doped refractory metal

RL: MOA (Modifier or additive use); NUU (Other use, unclassified); USES

```
seed layer)
IT
    165807-23-8, Chromium 95, titanium 5 (atomic)
    RL: DEV (Device component use); PEP (Physical, engineering or chemical
    process); TEM (Technical or engineered material use); PROC (Process); USES
        (underlayer coating; thin film magnetic disk having reactive element
       doped refractory metal seed layer)
             THERE ARE 13 CITED REFERENCES AVAILABLE FOR THIS RECORD
RE.CNT
RE
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    ANSWER 8 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
ΑN
    2000:687916 CAPLUS
    133:246419
DN
    Magnetic data-storage sputtering targets and methods for preparation
ΤI
    Bartholomeusz, Michael; Tsai, Michael
IN
PΑ
    Heraeus, Inc., USA
SO
    U.S., 35 pp.
    CODEN: USXXAM
DT
    Patent
LA
    English
    ICM H01F001-14
IC
NCL 148312000
CC
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56
FAN.CNT 1
                                         APPLICATION NO. DATE
     PATENT NO.
                    KIND DATE
     ______
    US 6123783
PΙ
                    A 20000926
                                       US 1997-946360 19971007
                     B1 20020813
                                         US 2000-546015 20000410
    US 6432223
PRAI US 1997-38031P P 19970206
US 1997-946360 A3 19971007
    A method for making a magnetic data storage target includes warm-rolling a
AB
    magnetic alloy sheet at a temp. of .ltorsim.1200.degree. F., optimally
     followed by annealing. The method results in increased pass-through-flux
     (PTF) and improved performance in magnetron sputtering applications.
    magnetic recording sputtering target rolling
ST
     annealing; alloy magnetic recording sputtering target
     rolling annealing; metal magnetic recording sputtering
     target rolling annealing
ΙT
    Magnetic recording materials
    Magnetron sputtering
     Sputtering targets
        (magnetic data-storage sputtering targets and methods for prepn.)
IT
     Annealing
     Cold rolling
        (magnetic data-storage sputtering targets and methods for prepn. using)
     Alloys, processes
IT
     Metals, processes
     RL: PEP (Physical, engineering or chemical process); TEM (Technical or
     engineered material use); PROC (Process); USES (Uses)
        (magnetic; magnetic data-storage sputtering targets and methods for
```

prepn.) IT Rolling (metals) (warm; magnetic data-storage sputtering targets and methods for prepn. TT Cobalt alloy, base Nickel alloy, base RL: NUU (Other use, unclassified); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (magnetic data-storage sputtering targets and methods for prepn.) 7440-02-0, Nickel, processes 7440-48-4, Cobalt, processes 159455-25-1, IT Chromium 10, cobalt 86, tantalum 4 (atomic) 228254-68-0, Chromium 12, cobalt 74, nickel 10, tantalum 4 (atomic) 256455-58-0, Chromium 15, cobalt 75, platinum 6, tantalum 4 (atomic) 293741-83-0, Chromium 16, cobalt 73, platinum 11 (atomic) 293741-84-1, Boron 6, chromium 20, cobalt 64, platinum 10 (atomic) 293741-85-2, Chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8 (atomic) 293741-86-3, Chromium 0-40, cobalt 0-100, nickel 0-100, platinum 0-30, tantalum 0-8 (atomic) 293741-87-4, Boron 0-30, chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8 (atomic) 293741-88-5, Chromium 0-40, cobalt 0-100, nickel 0-100, silicon 0-30, tantalum 0-8 (atomic) 293741-89-6, Chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8, zirconium 0-30 (atomic) 293741-90-9, Chromium 0-40, cobalt 0-100, iron 0-30, nickel 0-100, tantalum 0-8 (atomic) 293741-91-0, Chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8, tungsten 0-30 (atomic) 293741-92-1, Chromium 0-40, cobalt 0-100, molybdenum 0-30, nickel 0-100, tantalum 0-8 (atomic) 293741-93-2, Chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8, 293741-94-3, Chromium 0-40, cobalt 0-100, nickel vanadium 0-30 (atomic) 0-100, niobium 0-30, tantalum 0-8 (atomic) 293741-95-4, Chromium 0-40, cobalt 0-100, hafnium 0-30, nickel 0-100, tantalum 0-8 (atomic) 293741-96-5, Chromium 0-40, cobalt 0-100, nickel 0-100, tantalum 0-8, titanium 0-30 (atomic) 293741-97-6, Chromium 0-40, cobalt 0-100, nickel 0-100, samarium 0-30, tantalum 0-8 (atomic) RL: NUU (Other use, unclassified); PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses) (magnetic data-storage sputtering targets and methods for prepn.) RE.CNT THERE ARE 5 CITED REFERENCES AVAILABLE FOR THIS RECORD RE(1) Anon; JP 1100219 1989 (2) Chan, L; Journal of Magnetism and Magnetic Materials 1989, V79, P95 CAPLUS (3) Inoue; US 5500057 1996 CAPLUS (4) Taniguchi; US 5334267 1994 CAPLUS (5) Weigert, M; Materials Science and Engineering 1991, VA139, P359 CAPLUS L9 ANSWER 9 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN AN 2000:643293 CAPLUS DN 133:260589 ΤI Magnetic recording media Futamoto, Masaaki; Inaba, Nobuyuki; Hirayama, Yoshiyuki; Takeuchi, IN Teruaki; Honda, Yukio PA Hitachi, Ltd., Japan SO Jpn. Kokai Tokkyo Koho, 11 pp. CODEN: JKXXAF DTPatent Japanese LAICM G11B005-66 IC CC 77-8 (Magnetic Phenomena) FAN.CNT 2 PATENT NO. KIND DATE APPLICATION NO. DATE ΡI JP 2000251237 A2 20000914 JP 1999-45884 19990224 JP 3157806 B2 20010416 US 6383667 B1 20020507 US 1999-413813 19991007

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US 2002068199
                     A1
                         20020606
                                       US 2001-1995
                                                          20011205
                     B2
     US 6541125
                           20030401
                     Α
PRAI JP 1998-288134
                           19981009
                     Α
     JP 1999-45884
                           19990224
     US 1999-413813
                     A1
                           19991007
     The recording media comprise Co alloy magnetic films and Co-Crx-My base
AΒ
     films, where M = nonmagnetic elements such as B, and 25 .ltoreq. <math>x + y
     .ltoreg. 50 (at.%).
     magnetic recording media cobalt alloy
st
IT
     Magnetic films
      Magnetic recording materials
        (magnetic recording media with Co alloy magnetic
        films)
IT
     Cobalt alloy, base
     RL: DEV (Device component use); USES (Uses)
        (magnetic recording media with magnetic films from)
ΙT
     294626-73-6, Boron 6, chromium 25, cobalt 69 (atomic)
     294626-75-8, Chromium 25, cobalt 67, silicon 8 (atomic)
                                                             294626-77-0,
     Chromium 25, cobalt 65, germanium 10 (atomic)
                                                  294626-79-2, Aluminum 4,
     chromium 25, cobalt 71 (atomic) 294626-81-6, Chromium 25, cobalt 69,
     phosphorus 6 (atomic)
                           294626-83-8, Chromium 25, cobalt 69, titanium 6
              294626-85-0, Chromium 25, cobalt 65, vanadium 10 (atomic)
     294626-87-2, Chromium 25, cobalt 71, zirconium 4 (atomic)
     Chromium 25, cobalt 67, niobium 8 (atomic) 294626-91-8, Chromium 25,
     cobalt 69, hafnium 6 (atomic)
                                    294626-93-0, Chromium 25, cobalt 65,
     manganese 10 (atomic)
                            294626-95-2, Chromium 25, cobalt 63, rhodium 12
              294626-97-4, Chromium 25, cobalt 57, iridium 18 (atomic)
     294626-99-6, Chromium 25, cobalt 61, rhenium 14 (atomic) 294627-01-3,
     Chromium 25, cobalt 67, palladium 8 (atomic) 294627-03-5, Chromium 25,
     cobalt 69, platinum 6 (atomic) 294627-05-7, Chromium 25, cobalt 71,
     molybdenum 4 (atomic) 294627-07-9, Chromium 25, cobalt 67, tungsten 8
             294627-09-1, Chromium 25, cobalt 71, silver 4 (atomic)
     294627-11-5, Chromium 25, cobalt 69, gold 6 (atomic)
     RL: DEV (Device component use); USES (Uses)
        (magnetic recording media with base films from)
L9
    ANSWER 10 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
AN
     1999:748197 CAPLUS
DN
ΤI
     Thin film disk with acicular magnetic grains
    Marinero, Ernesto Esteban; Reith, Timothy Martin; York, Brian Rodrick
IN
PΑ
     International Business Machines Corporation, USA
SO
    U.S., 9 pp.
     CODEN: USXXAM
DT
     Patent
     English
LA
IC
     ICM G11B005-66
NCL
    428065300
     77-8 (Magnetic Phenomena)
CC
FAN.CNT 1
                     KIND DATE
                                        APPLICATION NO. DATE
     ------
                                         -----
    US 5989674
                          19991123
PI
                    Α
                                        US 1998-79907
                                                         19980515
     SG 87030
                     A1 20020319
                                         SG 1999-2139
                                                         19990507
PRAI US 1998-79907
                     Α
                          19980515
    A thin film disk and a disk drive using the thin film disk are described.
    The disk has a thin film magnetic layer composed of small acicular grains
    having an av. aspect ratio greater than one which results in improved
     recording performance. The development of the acicularity is aided
    through the crystal structure having anisotropic inplane stress with a
    radial stress being less than a tangential stress. The preferred magnetic
    material is an alloy Co which includes a glass forming material such as B,
    B oxide, Si, Si oxide, C, P, etc. The typical hcp. unit cells form
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acicular grains with a tendency for the C-axis to be orthogonal to a long

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axis of the acicular grains. Preferably the C-axis of the grains is
     oriented along the circumferential direction of the disk. Preferably the
     underlayer is sputtered deposited using neg. bias.
ST
     film disk acicular magnetic grain recording device; crystal structure
     orientation axis mech stress magnetic recording
     device; material magnetic cobalt glass forming boron silicon oxide device;
     sputtering deposition neg potential bias substrate magnetic
     recording device
IT
     Grains (particles)
        (magnetic; thin film disk with acicular magnetic grains)
     Glass, processes
IT
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
    process); PROC (Process); USES (Uses)
        (substrate; thin film disk with acicular magnetic grains)
IT
    Bias potential
        (surface substrate while sputtering; thin film disk with acicular
        magnetic grains)
IT
     Crystal orientation
     Crystal structure
     Magnetic films
     Magnetic memory devices
       Magnetic recording
     Sputtering
     Stress, mechanical
        (thin film disk with acicular magnetic grains)
TT
     1303-86-2, Boron oxide, processes 7440-42-8, Boron, processes
     7440-44-0, Carbon, processes
                                   7631-86-9, Silicon oxide, processes
     7723-14-0, Phosphorus, processes
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
    process); PROC (Process); USES (Uses)
        (glass forming material; thin film disk with acicular magnetic grains)
TΤ
     7440-48-4, Cobalt, processes
                                   54426-05-0, Cobalt alloy, Co, B
     177899-00-2, Cobalt alloy, Co,B,Cr,Pt
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
    process); PROC (Process); USES (Uses)
        (magnetic material; thin film disk with acicular magnetic grains)
TT
     7440-47-3, Chromium, processes
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
    process); PROC (Process); USES (Uses)
        (substrate underlayer; thin film disk with acicular magnetic grains)
TΤ
     12035-46-0, Nickel phosphide (NiP)
                                          12615-43-9, Aluminum 50, magnesium 50
     (atomic)
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
     process); PROC (Process); USES (Uses)
        (substrate; thin film disk with acicular magnetic grains)
TТ
     7440-21-3, Silicon, processes 249647-15-2, Boron 2-20, chromium
     10-23, cobalt 45-84, platinum 4-12 (atomic)
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
     process); PROC (Process); USES (Uses)
        (thin film disk with acicular magnetic grains)
RE.CNT
              THERE ARE 15 CITED REFERENCES AVAILABLE FOR THIS RECORD
        15
RE
(1) Arnoldussen, T; IEEE Trans on Magnetics 1984, VMAG-20(5), P821
(2) Baseman; US 5053250 1991 CAPLUS
(3) Chen; US 4405677 1983 CAPLUS
(4) Doerner; US 5523173 1996
(5) Hedgcoth; US 4735840 1988 CAPLUS
(6) Jones; US 5490809 1996
(7) Kawamoto, A; J Appl Phys 1991, V69(8), P5151 CAPLUS
(8) Kneller; US 4287225 1981 CAPLUS
(9) Laughlin, E; IEEE Trans on Magnetics 1996, V32(5), P3632
(10) Miyamoto; US 5352501 1994
(11) Nakamura; US 5147734 1992 CAPLUS
(12) Shimizu; US 5516547 1996 CAPLUS
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(13) Teng; US 5620574 1997
(14) Teng, E; IEEE Trans on Magnetics 1986, VMAG-22(5), P579
(15) Togawa; US 4480004 1984 CAPLUS
     ANSWER 11 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
     1996:212161 CAPLUS
DN
     124:305319
     Metal film magnetic recording material
TI
IN
     Yo, Kyoha; Akita, Ken; Maeda, Makoto; Okumura, Yoshinobu
     Kubota Kk, Japan
PA
     Jpn. Kokai Tokkyo Koho, 4 pp.
SO
     CODEN: JKXXAF
DT
     Patent
LA
     Japanese
     ICM H01F010-16
IC
     ICS G11B005-66
     77-8 (Magnetic Phenomena)
     Section cross-reference(s): 56
FAN. CNT 1
     PATENT NO.
                     KIND DATE
                                          APPLICATION NO. DATE
                     ----
                      A2
                          19960202
     JP 08031638
                                           JP 1994-164122
                                                            19940715
PRAI JP 1994-164122
                           19940715
     The material consists of a nonmagnetic support successively coated with an
     underlayer, a Co alloy magnetic layer contg. Cr 6-20, Ta .ltoreq.9, and Cu
     0.5-7 at.%, and a protective layer. The material may contain .ltoreq.20
     at. % Pt and .ltoreq.8 at. % B. The material shows high coercive force.
ST
     recording magnetic cobalt alloy
IT
     Recording materials
        (magnetic, magnetic recording material having
        copper-contg. cobalt alloy magnetic layer with high coercive force)
IT
     175785-17-8
                  175785-18-9 175785-19-0 175863-41-9
                                                            175863-42-0
     175863-43-1
     RL: DEV (Device component use); USES (Uses)
        (magnetic recording material having copper-contg.
        cobalt alloy magnetic layer with high coercive force)
IT
     175785-16-7
     RL: DEV (Device component use); TEM (Technical or engineered material
     use); USES (Uses)
        (magnetic recording material having copper-contg.
        cobalt alloy magnetic layer with high coercive force)
     7440-50-8, Copper, uses
IT
     RL: DEV (Device component use); MOA (Modifier or additive use); USES
     (Uses)
        (microalloying element; magnetic recording material
        having copper-contg. cobalt alloy magnetic layer with high coercive
        force)
     7440-44-0, Carbon, uses
IT
     RL: DEV (Device component use); USES (Uses)
        (protective layer; magnetic recording material
        having copper-contg. cobalt alloy magnetic layer with high coercive
        force)
IT
     7429-90-5, Aluminum, uses
                                 11149-64-7
     RL: DEV (Device component use); USES (Uses)
        (substrate; magnetic recording material having
        copper-contg. cobalt alloy magnetic layer with high coercive force)
IT
     7440-47-3, Chromium, uses
     RL: DEV (Device component use); USES (Uses)
        (underlayer; magnetic recording material having
        copper-contg. cobalt alloy magnetic layer with high coercive force)
    ANSWER 12 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
     1996:172175 CAPLUS
DN
     124:276598
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Magnetic disk recording medium
TI
IN
    Yokoyama, Fumiaki
     Mitsubishi Chemical Corp., Japan
PΑ
     U.S., 13 pp. Cont. of U.S. Ser. No. 500,994, abandoned.
SO
     CODEN: USXXAM
DT
     Patent
LA
     English
IC
     ICM B32B003-02
     ICS G11B005-66; C23C014-00
NCL
    428065300
     77-8 (Magnetic Phenomena)
CC
FAN.CNT 1
     PATENT NO.
                   KIND DATE
                                        APPLICATION NO. DATE
                                        -----
     -----
                                        US 1994-194636 19940210
    US 5492745
                   A 19960220
PRAI JP 1989-84945
                          19890404
    JP 1989-84947 19890404
US 1990-500994 19900329
     A magnetic recording medium comprises a nonmagnetic
     substrate and a magnetic alloy layer formed on the substrate with a
     nonmagnetic primer layer contq. Cr as the main component interposed
     between them, where the magnetic alloy layer contains Co and Ni as the
     main components and .ltoreq.8 at. B and has been formed by sputtering
     under such a condition that a neg. bias voltage is applied to the
     nonmagnetic substrate.
ST
     magnetic disk recording medium
IT
     Sputtering
        (deposition by; of cobalt alloy layers for magnetic
        recording disks)
IT
     Recording materials
        (magnetic, cobalt alloy sputtered layers for disks)
     134762-92-8, Boron 3, cobalt 67, nickel 30 (atomic) 175081-84-2, Boron
IT
     0.4, cobalt 79.7, nickel 19.9 (atomic) 175081-85-3, Boron 1, cobalt
     79.2, nickel 19.8 (atomic) 175081-86-4, Boron 2.3, cobalt 78.2, nickel
     19.5 (atomic) 175081-87-5, Boron 3.7, cobalt 77, nickel 19.3 (atomic)
     175081-88-6, Boron 6, cobalt 75.2, nickel 18.8 (atomic) 175081-89-7,
     Boron 8, cobalt 73.6, nickel 18.4 (atomic)
                                               175081-90-0, Boron 2.3,
     cobalt 66.1, nickel 31.6 (atomic) 175081-91-1, Boron 1, chromium 7.9,
     cobalt 73.4, nickel 17.7 (atomic) 175081-92-2, Boron 3.7, chromium 7.7,
     cobalt 71.3, nickel 17.3 (atomic) 175081-93-3, Boron 5, chromium 7.6,
     cobalt 70.3, nickel 17.1 (atomic) 175081-94-4, Boron 8, chromium 7.4,
     cobalt 68, nickel 16.6 (atomic) 175081-95-5, Boron 3, chromium 7, cobalt
     61, nickel 29 (atomic) 175385-91-8, Boron 1-7, chromium 5-26,
     cobalt 40-94, nickel 0-27 (atomic)
     RL: DEV (Device component use); PEP (Physical, engineering or chemical
     process); PROC (Process); USES (Uses)
        (magnetic disk recording materials having sputtered layers of)
     ANSWER 13 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
     1995:924223 CAPLUS
DN
     123:347029
ΤI
     Structural design of CoCrPt(Ta,B)/Cr magnetic thin film media for ultra
     high density longitudinal magnetic recording
ΑU
     Glijer, Pawel; Sin, Kyusik; Sivertsen, John M.; Judy, Jack H.
CS
     Cent. Micromagnetics Inf. Technol., Univ. Minnesota, Minneapolis, MN,
     55455, USA
     Scripta Metallurgica et Materialia (1995), 33(10/11), 1575-84
SO
     CODEN: SCRMEX; ISSN: 0956-716X
PB
     Elsevier
DT
     Journal
LΑ
     English
     56-8 (Nonferrous Metals and Alloys)
CC
     Section cross-reference(s): 77
     CoCrPt(Ta,B) thin films with Cr underlayers were studied as potential
AB
```

candidates for ultra-high d. magnetic recording media
for data storage at 10 Gbits/in. The exptl. approach used was aimed at an
anal. of the structure-properties relationships in these thin films. As a
result structural and compn. changes resulting in magnetic and noise
properties have been identified. It has been shown that very high
in-plane coercivities of 2700 Oe and above could be obtained in CoCrPt
films with Pt contents <20 at.%; in CoCrPtTa for Pt contents <12% Pt (with
2.5-5% Ta) and in CoCrPtB (with 3-7% B) for Pt contents <11%. Also
methods for improvement of coercivity squareness, noise characteristics
and refinement of grain size and surface roughness have been demonstrated.
structural design magnetic thin film; cobalt alloy magnetic thin film;
longitudinal magnetic recording film

IT Recording materials

(magnetic, ultra high d. longitudinal; structural design of CoCrPt(Ta,B)/Cr magnetic thin film media for)

IT 170892-83-8

ST

RL: PRP (Properties)

(structural design of CoCrPt(Ta,B)/Cr magnetic thin film media for ultra high d. longitudinal magnetic recording)

TT 7440-47-3, Chromium, properties 159828-68-9, Chromium 13, cobalt 74,
 platinum 13 (atomic) 159828-70-3, Boron 8, chromium 17, cobalt
 72, platinum 3 (atomic) 170892-84-9 170892-85-0
 RL: PRP (Properties); TEM (Technical or engineered material use); USES
 (Uses)

(structural design of CoCrPt(Ta,B)/Cr magnetic thin film media for ultra high d. longitudinal magnetic recording)

- L9 ANSWER 14 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
- AN 1995:63037 CAPLUS
- DN 122:44686
- TI Remanent magnetization study of magnetic interactions in CoCrPtB/Cr thin films
- AU Glijer, Pawel; Sivertsen, John M.; Judy, Jack H.
- CS Department of Chemical Engineering and Materials Science, University of Minnesota, Minneapolis, MN, 55455, USA
- Proceedings Electrochemical Society (1994), 94-6 (Magnetic Materials, Processes, and Devices), 235-47 CODEN: PESODO; ISSN: 0161-6374
- DT Journal
- LA English
- CC 77-8 (Magnetic Phenomena)
- AB High coercivity CoCrPtB/Cr thin films are considered good candidates for very high d. longitudinal magnetic recording media. Such media should have high coercivity, very low noise and low remanent magnetization-thickness product (Mr.delta.). Remanent magnetization studies of low Mr.delta. product CoCrPtB/Cr thin films with different compns. were performed. Anal. of the remanent behavior of the films. allows for estn. of intergranular interactions and noise of the medium. Addn. of B and Pt causes coercivity increase (up to 3600 Oe) and also magnetic decoupling of the grains in the film. The dc-erase remanent curves obtained show that grains or groups of grains in the CoCrPtB films switch independently of each other. This result as well as small grain diams. obsd. in CoCrPtB films suggest that possible pptn. of borides on the grain boundaries decouples exchange interactions between grains of the magnetic films. Such decoupled CoCrPtB/Cr films exhibit very low noise at high recording densities.
- ST cobalt chromium platinum boron recording film
- IT Coercive force, magnetic

Magnetic remanence

(remanent magnetization study of magnetic interactions in CoCrPtB/Cr recording films)

IT Recording materials

(magnetic, film; remanent magnetization study of magnetic interactions in CoCrPtB/Cr recording films)

```
7440-47-3, Chromium, properties 84241-62-3, Chromium 16, cobalt 84
IT
             159828-67-8, Chromium 15, cobalt 82, platinum 3 (atomic)
    159828-68-9, Chromium 13, cobalt 74 platinum 13 (atomic)
    159828-69-0, Boron 10 chromium 16, cobalt 74 (atomic)
     159828-70-3, Boron 8 chromium 17 cobalt 72 platinum 3 (atomic)
     159828-71-4, Boron 5 chromium 11 cobalt 81 platinum 3 (atomic)
     159828-72-5, Boron 5 chromium 14 cobalt 69 platinum 12 (atomic)
    RL: DEV (Device component use); PRP (Properties); TEM (Technical or
     engineered material use); USES (Uses)
        (remanent magnetization study of magnetic interactions in CoCrPtB/Cr
        recording films)
    ANSWER 15 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
    1994:181453 CAPLUS
DN
ΤI
    Sputtering target material for magnetic recording film
    and its manufacture
IN
    Okumura, Yoshinobu; Funakoshi, Atsushi; Nishi, Takashi
    Kubota Kk, Japan
PA
SO
    Jpn. Kokai Tokkyo Koho, 5 pp.
    CODEN: JKXXAF
DT
    Patent
LA
    Japanese
    ICM C23C014-34
IC
     ICS C22C001-04; C22C019-07
     77-8 (Magnetic Phenomena)
    Section cross-reference(s): 56
FAN.CNT 1
    PATENT NO.
                    KIND DATE
                                          APPLICATION NO. DATE
     -----
PI JP 05263232 A2 19931012
PRAI JP 1992-92227 19920317
                                          JP 1992-92227 19920317
    The material with relative d. .gtoreq.98% consists of a Co alloy sintered
    body contq. 6-17 at. % Cr and 0.8-10 at. % B. The material is manufd. by
     filling a metal vessel with atomized alloy powders with the above compns.
    and particle size .ltoreq.22 mesh, degassing, sealing up, and HIP(hot
     isostatic pressing) - sintering. The obtained film showed good coercive
     force and square-loop ratio.
    cobalt alloy sputtering target HIP; recording magnetic
ST
    cobalt alloy target; boron chromium cobalt alloy target
IT
    Recording materials
        (magnetic, cobalt alloy film, sputtering target for, HIP sintering of,
       with good coercive force and square-loop ratio)
IT
     Sputtering
        (targets, cobalt alloy, HIP sintering of, for magnetic
       recording film, with good coercive force and square-loop ratio)
IT
    153563-19-0 153563-20-3 153563-21-4
    153563-22-5 153563-23-6
    RL: USES (Uses)
        (sputtering target, HIP sintering of, for magnetic
        recording film, with good coercive force and square-loop ratio)
    ANSWER 16 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
    1990:543745 CAPLUS
AN
DN
    Phases and magnetic properties of the devitrified metallic glasses
TI
     cobalt-chromium-boron (Co66Cr14B20) and iron-chromium-nickel-boron
     (Fe43Cr25Ni20B12)
    Henderson, L.; O'Handley, R. C.; Averbach, B. L.
AU
    Dep. Mater. Sci. Eng., Massachusetts Inst. Technol., Cambridge, MA, 02139,
CS
    Journal of Magnetism and Magnetic Materials (1990), 87(1-2), 142-6
so
     CODEN: JMMMDC; ISSN: 0304-8853
    Journal
DT
```

```
English
LA
CC
     77-1 (Magnetic Phenomena)
     Section cross-reference(s): 55, 56
     Devitrification of amorphous melt-spun ribbons with compns. of Co66Cr14B20
AB
     and Fe43Cr25Ni20B12 was investigated as a method of making fine
     dispersions of magnetic phases within a non-magnetic matrix. Such a
     process may ultimately be applied to amorphous films to produce
     solid-state dispersions of particles that possess magnetic properties
     suitable for magnetic recording purposes. The ribbons
     were isochronally annealed so as the cause a large no. of magnetic
     particles to ppt. out of a glassy matrix. The Co-based ribbons
     devitrified to form a series of Cr-borides and cubic (CoCr)23B6.
     coercivity and satn. magnetization varied systematically with
     heat-treatment temp., both reaching their max. values of 530 Oe and
     approx. 300 G for TA = 610.degree.. The Fe-based ribbons first
     devitrified to form ferromagnetic .alpha.-iron which transformed to
     paramagnetic Ni-rich austenite upon annealing at higher temps. The
     annealed Fe-based ribbons displayed a max. specific magnetization of
     approx. 400 G and a max. coercivity of 424 Oe. However, these two
     properties are not maximized at the same temp.
ST
     coercivity metallic glass devitrification; magnetization metallic glass
     devitrification; cobalt alloy glass devitritrication magnetism; iron alloy
     glass devitritrication magnetism; chromium alloy glass devitritrication
     magnetism; phase compn devitrification VIII alloy glass
IT
     Coercive force, magnetic
     Magnetic induction and Magnetization
        (of boron-chromium-cobalt and boron-chromium-iron-nickel devitrified
        metallic glasses)
     Metallic glasses
TT
     RL: USES (Uses)
        (boron-chromium-cobalt, magnetic properties and phase decompn. of
        devitrified)
IT
    Metallic glasses
     RL: USES (Uses)
        (boron-chromium-iron-nickel, magnetic properties and phase decompn. of
        devitrified)
     99628-38-3, Boron 12, chromium 25, iron 43, nickel 20 (atomic)
ΙT
     129517-57-3, Boron 20, chromium 14, cobalt 66 (atomic)
     RL: PRP (Properties)
        (magnetic properties and phases o devitrified glassy)
    ANSWER 17 OF 17 CAPLUS COPYRIGHT 2003 ACS on STN
L9
AN
     1986:140849 CAPLUS
     104:140849
DN
    Magnetic recording medium
TI
     Shirahata, Ryuji; Tamai, Yasuo; Kitamoto, Tatsuji
IN
PA
     Fuji Photo Film Co., Ltd., Japan
     Jpn. Tokkyo Koho, 4 pp.
SO
     CODEN: JAXXAD
DT
     Patent
LA
     Japanese
IC
    H01F001-04; G11B005-66
     77-8 (Magnetic Phenomena)
CC
     Section cross-reference(s): 56
FAN.CNT 1
     PATENT NO.
                      KIND DATE
                                           APPLICATION NO. DATE
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     JP 60032964
                      B4
                            19850731
                                           JP 1977-153428
                                                            19771220
                     A2
                            19790706
     JP 54085398
PRAI JP 1977-153428
                            19771220
    The fabrication of a wear-resistant magnetic recording
    medium involves vacuum deposition or ion plating of a ferromagnetic metal
     thin film (e.g., Co 97-99.8, B 0.2-3.0) contg. Co .gtoreq.75, B 0.2-3.0,
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and N 0-2.0 wt.% on a nonmagnetic substrate.

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